| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|------------------------|------------------|
| 3 | 195 | (((((mems or microelectromechanical or (micro adj electro | USPAT; | 2003/10/21 10:55 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB; | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array | EPO; JPO; DERWENT: | |
| | | | IBM TDB | |
| 4 | 7 | ((((((mems or microelectromechanical or (micro adj electro | USPAT: | 2003/10/21 10:54 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB: | 2003/10/21 10:54 |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | EPO: JPO: | 1 |
| | | (pass near3 transistor) | DERWENT: | |
| | | The state of the s | IBM TDB | 1 |
| 5 | 9 | ((((((mems or microelectromechanical or (micro adj electro | USPAT; | 2003/10/21 10:55 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB; | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | EPO; JPO; | |
| | | (voltage\$1 near3 transistor\$1) | DERWENT; | i i |
| | | | IBM_TDB | |
| 6 | 195 | (((((mems or microelectromechanical or (micro adj electro | USPAT; | 2003/10/21 10:55 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB; EPO: JPO: | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array | DERWENT: | |
| | | | IBM TDB | |
| 7 | 9 | ((((((mems or microelectromechanical or (micro adj electro | USPAT: | 2003/10/21 10:59 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB: | 2000/10/21 10:00 |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | EPO: JPO: | |
| | | (voltage\$1 near3 transistor\$1) | DERWENT: | |
| | | , | IBM TDB | |
| 8 | 28 | ((((((mems or microelectromechanical or (micro adj electro | USPAT; | 2003/10/21 10:59 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB; | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | EPO; JPO; | |
| | | (voltage\$1 same transistor\$1) | DERWENT; | |
| | | | IBM_TDB | |
| 9 | 19 | (((((((mems or microelectromechanical or (micro adj electro | USPAT; | 2003/10/21 10:59 |
| | | adj mechanical)) and (torsion)) and substrate\$1) and | US-PGPUB; | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | DERWENT: | l . |
| | | (voltage\$1 same transistor\$1)) not ((((((mems or microelectromechanical or (micro adj electro adj | IBM TDB | |
| | | mechanical)) and (torsion)) and substrate\$1) and | I I DIWI_ I DB | |
| | | (electrode\$1 and voltage\$1)) and switch\$3) and array) and | | |
| | | (voltage\$1 near3 transistor\$1)) | 1 | |